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Docket No.: 2336-254

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Sun Woon KIM

U.S. Patent Application No. 10/806,432

Filed: March 23, 2004

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Confirmation No.2939

Group Art Unit: 2812

Examiner: RICHARD A. BOOTH

For: FABRICATION METHOD OF NITRIDE SEMICONDUCTORS AND NITRIDE
SEMICONDUCTOR STRUCTURE FABRICATED THEREBYRESPONSE TO RESTRICTION REQUIREMENTCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

By Official Action mailed August 15, 2005 restriction to one of the following inventions is required under 35 USC 121:

In response, Applicants hereby elect Species 1 (Fig. 1), claims 1-6 being readable thereon for examination in this case.

A divisional application will be filed for the non-elected claims.

CERTIFICATION OF FACSIMILE TRANSMISSION
I HEREBY CERTIFY THAT THIS PAPER IS BEING FACSIMI-
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571-273-8300

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